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SERIAL NUMBER 10/691,108	FILING OR 371(c) DATE 10/22/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 10191/3399
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APPLICANTS

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** CONTINUING DATA ***** NONE IV

** FOREIGN APPLICATIONS ***** YES IV
 GERMANY 102 49350.2 10/23/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED **
 01/22/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY GERMANY	SHEETS DRAWING 9	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <u>[Signature]</u> Initials: <u>LV</u>				

ADDRESS

26646

TITLE

Device and method for anisotropic plasma etching of a substrate, particularly a silicon element

FILING FEE RECEIVED 986	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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